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Docket No.: 1794-0141P  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yoshinobu AOYAGI et al.

Application No.: 09/941,612

Confirmation No.: 6758

Filed: August 30, 2001

Art Unit: 1792

For: IMPURITY DOPING METHOD FOR  
SEMICONDUCTOR AS WELL AS SYSTEM  
THEREFOR AND SEMICONDUCTOR  
MATERIALS PREPARED THEREBY

Examiner: M. J. Song

**AMENDMENT AFTER FINAL OFFICE ACTION**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Madam:

**INTRODUCTORY COMMENTS**

In response to the Examiner's Office Action dated December 23, 2008, the period for response having been extended three (3) month to June 23, 2009, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

**This reply includes**

**Amendments to the Claims; and**

**Remarks.**